

B

Docket No.: 60188-431

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Akihiko ISHIBASHI, et al. : Confirmation Number: 6491
Serial No.: 10/017,389 : Group Art Unit: 2818
Filed: December 18, 2001 : Allowed: November 10, 2003
Examiner: Mai Huong C. Tran

For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING DEVICE

LETTER UNDER 37 CFR 1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated November 10, 2003. The title, as it appears on the Notice of Allowance, is incorrect. The title should read METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING DEVICE. This information appeared correctly on the executed Declaration filed December 18, 2001.

It is respectfully requested that the records of the Patent Office be corrected to ensure that the deed of Letters Patent will be printed correctly.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:blp
Facsimile: (202) 756-8087
Date: December 16, 2003



Docket No.: 60188-431

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Akihiko ISHIBASHI, et al. : Confirmation Number: 6491
Serial No.: 10/017,389 : Group Art Unit: 2818
Filed: December 18, 2001 : Allowed: November 10, 2003
Examiner: Mai Huong C. Tran

For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING
SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING
DEVICE

REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated November 10, 2003.

In reviewing the file, it is noted that we have not received acknowledgement of the Information Disclosure Statement and cited art filed September 17, 2003. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and stamped return postcard acknowledgement.

Applicants hereby respectfully request that:

the appropriately acknowledged PTO-1449 be furnished to Applicants; and

the record be clarified to confirm that the cited art has been considered and made of record.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:blp
Facsimile: (202) 756-8087
Date: December 16, 2003

Applicant: Akihiko ISHIBASHI, et al. Docket No. 60188-431

Title: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING DEVICE Serial/Reg./Patent No. 10/017,389

Date Sent: 9/17/2003 ☒ Hand Carried ☐ Fax ☐ Electronic ☐ Cert. of Mailing ☐ Express Mail No. _____

☐ Transmittal Letter

New Patent App ☐ Utility ☐ Design ☐ CIP ☐ Div. ☐ PCT ☐ RCE ☐ Prov

☐ Other: _____

_____ pages of Specification

_____ pages of Claims

_____ pages of Abstract

_____ pages of Formal/Informal Drawings

☐ Small Entity ☐ Large Entity

☐ Declaration/Power of Attorney

☐ Recordation of Assignment/Security Agreement

☒ Information Disclosure Statement

1 Form PTO 1449

1 copies of cited references

☐ Preliminary Amendment

☐ Response to Missing Parts Notice

☐ Resp. to Notice to Correct App. Papers

☐ Certified Copy of Priority Doc.

☐ Claim for Convention Priority

☒ Response/Amendment to Office Action of July 22, 2003

☐ Request for _____ month Extension of Time

☐ Letter submitting _____ pages of drawings

☐ Req. for Approval of Drawing Amendments

☐ Req. for Oral Hearing

☐ Not. of Appeal ☐ Appeal Brief ☐ Reply Brief

☐ Rule 312 Amendment/Letter

☐ Req. for Acknowledgement of Cited Art

☐ Issue Fee

☐ Publication Fee

☐ Req. for Certificate of Correction

☐ Maintenance Fee for _____ years after grant

☐ Fee Address Indication Form

☐ Terminal Disclaimer

☐ Petition to Commissioner

☐ Status Inquiry

☐ Other

Check for \$	<input type="checkbox"/> Charge Deposit Acct. 500417\$	Atty Init.	MEF/ RMF	Tkpr. #	3328	Secy. or PL:	AM. Ziegler
--------------	--	------------	-------------	---------	------	--------------	-------------

CMS Descrip.: _____

THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.

COPY

Docket No.: 60188-431

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Akihiko ISHIBASHI, et al. : Confirmation Number: 6491
Serial No.: 10/017,389 : Group Art Unit: 2818
Filed: December 18, 2001 : Examiner: Mai Huong C. Tran
For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING
SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING
DEVICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached form PTO-1449. It is respectfully requested that the reference be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

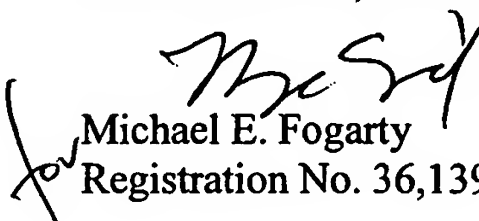
This Information Disclosure Statement ("IDS") is supplemental to the IDS filed on August 14, 2003, and includes a partial English translation of JP 10-150245 cited therein.

10/017,389

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

 #46,692
for Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:jgh
Facsimile: (202) 756-8087
Date: September 17, 2003

INFORMATION DISCLOSURE CITATION IN ANOTHER APPLICATION

(PTO-1449)


 ATTY. DOCKET NO.
60188-431

 SERIAL NO.
10/017,389

 APPLICANT
Akihiko ISHIBASHI, et al.

 FILING DATE
December 18, 2001

 GROUP
2818

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
	A	JP 10150245 with partial English translation	06/02/1998	Matsushita Electric Ind. Co. Ltd.			

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.